



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani, et al  
Serial No. : 08/690,747  
Filed : August 1, 1996  
Title : METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Art Unit : 1765  
Examiner : Robert Kunemund

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OCT 16 2003  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT SUBMITTED WITH REQUEST FOR CONTINUED EXAMINATION  
UNDER 37 CFR 1.114

Please amend the above-identified application as follows:

**Amendments to the Claims** begin at page 2 of this paper.

**Remarks/Arguments** begin on page 16 of this paper.